

Notice of Allowability

Application No.

10/811,414

Examiner

Anne M. Hines

Applicant(s)

LIU ET AL.

Art Unit

2879

-- The MAILING DATE of this communication appears on the cover sheet with the correspondence address--

All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. **THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS.** This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.

1. ☒ This communication is responsive to 1/10/2006.
2. ☒ The allowed claim(s) is/are 19-37.
3. ☒ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).
 - a) ☒ All b) ☐ Some* c) ☐ None of the:
 1. ☒ Certified copies of the priority documents have been received.
 2. ☐ Certified copies of the priority documents have been received in Application No. _____.
 3. ☐ Copies of the certified copies of the priority documents have been received in this national stage application from the International Bureau (PCT Rule 17.2(a)).

* Certified copies not received: _____.

Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application.

THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.

4. ☐ A SUBSTITUTE OATH OR DECLARATION must be submitted. Note the attached EXAMINER'S AMENDMENT or NOTICE OF INFORMAL PATENT APPLICATION (PTO-152) which gives reason(s) why the oath or declaration is deficient.
5. ☐ CORRECTED DRAWINGS (as "replacement sheets") must be submitted.
 - (a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached
 - 1) ☐ hereto or 2) ☐ to Paper No./Mail Date _____.
 - (b) ☐ including changes required by the attached Examiner's Amendment / Comment or in the Office action of Paper No./Mail Date _____.

Identifying indicia such as the application number (see 37 CFR 1.84(c)) should be written on the drawings in the front (not the back) of each sheet. Replacement sheet(s) should be labeled as such in the header according to 37 CFR 1.121(d).
6. ☐ DEPOSIT OF and/or INFORMATION about the deposit of BIOLOGICAL MATERIAL must be submitted. Note the attached Examiner's comment regarding REQUIREMENT FOR THE DEPOSIT OF BIOLOGICAL MATERIAL.

Attachment(s)

- | | |
|---|--|
| 1. <input type="checkbox"/> Notice of References Cited (PTO-892) | 5. <input type="checkbox"/> Notice of Informal Patent Application (PTO-152) |
| 2. <input type="checkbox"/> Notice of Draftsperson's Patent Drawing Review (PTO-948) | 6. <input type="checkbox"/> Interview Summary (PTO-413),
Paper No./Mail Date _____. |
| 3. <input type="checkbox"/> Information Disclosure Statements (PTO-1449 or PTO/SB/08),
Paper No./Mail Date _____ | 7. <input type="checkbox"/> Examiner's Amendment/Comment |
| 4. <input type="checkbox"/> Examiner's Comment Regarding Requirement for Deposit
of Biological Material | 8. <input type="checkbox"/> Examiner's Statement of Reasons for Allowance |
| | 9. <input type="checkbox"/> Other _____. |

DETAILED ACTION

Response to Amendment

The amendment filed on January 10, 2006 has been entered and acknowledged by the Examiner.

Claims 19-37 are pending in the instant application.

Allowable Subject Matter

Claims 19-37 are allowed.

Regarding independent claim 19, the references of the Prior Art of record fail to teach or suggest the combination of the limitations as set forth in claim 19, and specifically comprising the limitation wherein after providing a detachable substrate with a planar surface, forming the described gate electrodes on the planar surface of the detachable substrate, forming an intermediate layer on the gate electrodes, forming a catalyst layer on the intermediate layer, forming the described spacer on the catalyst layer, forming carbon nanotube arrays extending from the catalyst layer, and forming cathode electrodes on first ends of the carbon nanotube arrays the detachable substrate is removed, portions of the intermediate layer corresponding to positions of the carbon nanotube arrays are removed to expose opposite second ends of the carbon nanotube arrays to the gate electrodes.

Regarding claims 20-36, claims 20-36 are allowable for the reasons given in claim 19 because of their dependency status from claim 19.

Regarding independent claim 37, the references of the Prior Art of record fail to teach or suggest the combination of the limitations as set forth in claim 37, and specifically comprising the limitation wherein after providing a detachable substrate, locating a catalyst layer and a gate electrode on the substrate, growing carbon nanotube arrays on the catalyst layer with roots of the carbon nanotube arrays extending from the catalyst layer, locating a barrier on the substrate, disposing a cathode electrode on the barrier so that tips of carbon nanotubes of the carbon nanotube arrays are embedded in the cathode electrode the substrate and catalyst layer are removed to expose the roots of the carbon nanotubes adjacent to the gate electrode are exposed.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Anne M. Hines whose telephone number is (571) 272-2285. The examiner can normally be reached on Monday through Friday from 8:00-4:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nimesh Patel can be reached on (571) 272-2457. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see <http://pair-direct.uspto.gov>. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Anne M Hines
Patent Examiner
Art Unit 2879

Amtt
2/28/06

MSg 3/6/06
MARICELI SANTIAGO
PRIMARY EXAMINER